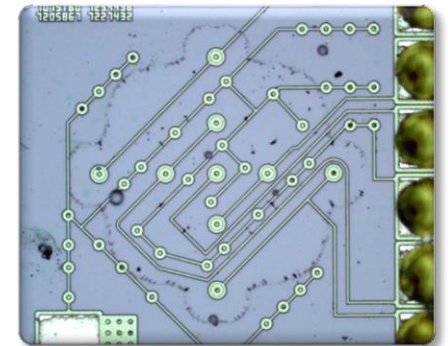
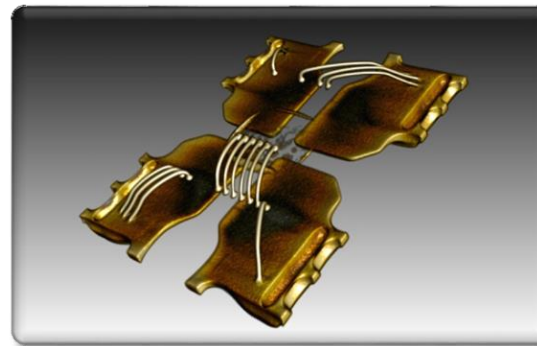
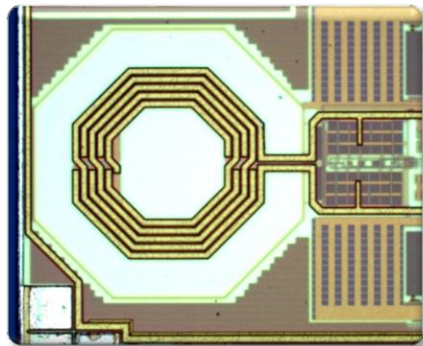


# SiT8103

## High Performance 1-110 MHz Oscillator



# Product Analysis Report

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